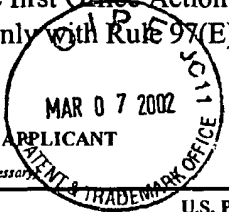


FORM PTO-1449      US DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		Atty. Docket No. <b>81258D / N-R</b> Customer No. 01333		Serial No. <b>10/025,363</b>	
If AFTER the later date of the first Office Action or 3 months from filing, use only with Rule 97(E) Certificate or Fee		Applicant: <b>Constantine N. Anagnostopoulos, et al</b>			
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)		Filing Date <b>December 19, 2001</b>		Group <b>2853 1763</b>	



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Examiner Initial*	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
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<i>M</i>	GB 2 007 162 A	2 October 1978	United Kingdom			
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*M* "CMOS INTEGRATED INK JET PRINT HEADS" by Constantine N. Anagnostopoulos, Eastman Kodak Company (April 4, 2000).

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M U.S. Patent Application No. 09/ 751,593 , filed December 29, 2000 and entitled: CMOS/MEMS INTEGRATED INK JET PRINT HEAD WITH OXIDE BASED LATERAL FLOW NOZZLE ARCHITECTURE AND METHOD OF FORMING SAME in the name of C. N. Anagnostopoulos et al.

M U.S. Patent Application No. 09/751,115 , filed December 29, 2000 and entitled: INCORPORATION OF SUPPLEMENTARY HEATERS IN THE INK CHANNELS OF CMOS/MEMS INTEGRATED INK JET PRINT HEAD AND METHOD OF FORMING SAME in the name of C. N. Anagnostopoulos et al.

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M U.S. Patent Application No. 09/731,355 filed December 6, 2000 and entitled: IMPROVED PAGE WIDE INK JET PRINTING, in the name of C. N. Anagnostopoulos et al.

EXAMINER <i>Robert V. Calbert</i>	DATE CONSIDERED <i>3/17/01</i>
<small>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</small>	